

# MONDAY 08:30 – 17:50

## Latest Advancements in Microwave Measurement Techniques for Future Communications and Quantum Applications

WM02  
EuMC

Chair: Xiaobang Shang<sup>1</sup>

Co-Chair: Nick Ridler<sup>1</sup>

<sup>1</sup>National Physical Laboratory (NPL), UK

**Room: Juliana 2**

This full-day workshop will explore the latest advancements in microwave measurement techniques. Topics covered include on-wafer S-parameter measurements at millimetre-wave and sub-terahertz frequencies, on-wafer noise figure measurements, microwave measurements at cryogenic temperatures, novel VNA calibration methods, millimetre-wave modulation effects in optical links, robot-based field measurement techniques, and the characterisation of dielectric materials at millimetre-wave frequencies, among others.

These advanced measurement techniques are crucial for the development of circuits

aimed at future communications and quantum applications. The workshop will feature twelve presentations by distinguished speakers from diverse scientific backgrounds, including representatives from metrology institutes, instrumentation manufacturers, and both industry and academia. This will provide attendees with a comprehensive overview of the topics discussed.

The workshop will conclude with a dedicated session for open discussions, offering an opportunity for both speakers and attendees to engage in a dialogue about

the challenges and opportunities facing the microwave measurement community in the years ahead. This interactive session will encourage contributions from all participants, fostering a collaborative exchange of ideas.

### PROGRAMME

#### On-wafer S-parameter Measurement at Millimetre-wave and Sub-terahertz Frequencies

Xiaobang Shang<sup>1</sup>

<sup>1</sup>National Physical Laboratory

#### Characterisation of a Commercial High Resistance Silicon Calibration Substrate at D-band

Gia Ngoc Phung<sup>1</sup>

<sup>1</sup>PTB, Germany

#### On Accuracy and Traceability of Wafer-Level Measurements at mm-Wave Frequencies

Andrej Rumiantssev<sup>1</sup>

<sup>1</sup>MPI Corporation, Taiwan

#### AIST's Cryogenic Testbed System Using High Transmission Line with High Thermal Insulation

Hiroyuki Kayano<sup>1</sup>

<sup>1</sup>Advanced Industrial Science and Technology (AIST), Japan

#### Working Towards A Large-scale Quantum Computer

James Kirkman<sup>1</sup>

<sup>1</sup>Quantum Motion, UK

#### Avoiding Pitfalls and Optimisation of RF/millimetre-wave Measurements at Cryogenic Temperatures

Gavin Fisher<sup>1</sup>

<sup>1</sup>FormFactor, Germany

#### R&D Development Challenges in RF and mmWave Lab for S-parameters and Noise Characterisation in an Industrial Environment

Joao Carlos Azevedo Goncalves<sup>1</sup>

<sup>1</sup>STMicroelectronics, France

#### Millimeter-wave modulation effects in optical links

Jon Martens<sup>1</sup>

<sup>1</sup>Anritsu, US

#### Recent Developments in VNA Calibration Techniques

Michael Ernst Gadringer<sup>1</sup>

<sup>1</sup>Graz University of Technology, Austria

#### Robot Based Microwave Measurement Technique

Jae-Yong Kwon<sup>1</sup>

<sup>1</sup>KRISS, South Korea

#### Radar Based Material Characterization Methods in the Millimetre-wave Range

Jan Barowski<sup>1</sup>

<sup>1</sup>Ruhr University Bochum, Germany

#### Broadband Material Characterization Using a Balanced-Type Circular Disk Resonator at Millimetre-wave and Sub-Terahertz Bands

Yuto Kato<sup>1</sup>

<sup>1</sup>National Metrology Institute of Japan, Japan